Search Notes			

Application/Control No.	Applicant(s)/Patent under Reexamination
10/652,497	KIM, DAE-HWAN
Examiner	Art Unit
Hai C. Pham	2861

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SEARCHED					
Class	Subclass	Date	Examiner		
347	134-135, 239, 241, 255	5/25/2006	HP		
349	193-202	5/25/2006	HP		
	120				
252	582-589	5/25/2006	НÞ		
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	

SEARCH NOT (INCLUDING SEARCH		
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EAST Text Search	5/25/2006	HP
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